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APPLICATIO	N NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/021,0	00	12/19/2001	Nobuo Takeshita	2257-0202P-SP	8807	
2292	7590	10/25/2006	•	EXAMINER		
		ART KOLASCH &	BIRCH	CHU, KIM KWOK		
	PO BOX 747 FALLS CHURCH, VA 22040-0747			ART UNIT	PAPER NUMBER	
	•	•	•	2627		
				DATE MAILED: 10/25/2006		

Please find below and/or attached an Office communication concerning this application or proceeding.

		Application No.	Applicant(s)				
		10/021,000	TAKESHITA, NC	TAKESHITA, NOBUO			
	Office Action Summary	Examiner	Art Unit				
		Kim-Kwok CHU	2627				
Period fo	 The MAILING DATE of this communicator Reply 	ion appears on the cover she	et with the correspondence a	ddress			
WHIC - Exte after - If NC - Failu Any	ORTENED STATUTORY PERIOD FOR CHEVER IS LONGER, FROM THE MAIL nsions of time may be available under the provisions of 37 SIX (6) MONTHS from the mailing date of this community of period for reply is specified above, the maximum statutor re to reply within the set or extended period for reply will, reply received by the Office later than three months after the patent term adjustment. See 37 CFR 1.704(b).	ING DATE OF THIS COMM 7 CFR 1.136(a). In no event, however, nation. ry period will apply and will expire SIX (6 by statute, cause the application to become	IUNICATION. nay a reply be timely filed NONTHS from the mailing date of this one ABANDONED (35 U.S.C. § 133).				
Status							
1)⊠	Responsive to communication(s) filed o	n Amendment filed on 9/20/2	2006.				
2a)□	_	This action is non-final.					
3)							
,,	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.						
Dispositi	on of Claims						
4)⊠	Claim(s) <u>1-11 and 13-19</u> is/are pending	in the application.		•			
•	4a) Of the above claim(s) is/are w	• •	1.				
	Claim(s) <u>1-11</u> is/are allowed.						
•	Claim(s) <u>13-19</u> is/are rejected.	•					
7)	Claim(s) is/are objected to.						
8)	Claim(s) are subject to restriction	and/or election requiremen	t.				
Applicati	on Papers						
	The specification is objected to by the Ex	vaminer					
-	The drawing(s) filed on <u>1/26/2005</u> is/are:		ected to by the Evaminer				
10/23	Applicant may not request that any objection	•	•				
	Replacement drawing sheet(s) including the	- · ·	•	PER 1 121(d)			
11)	The oath or declaration is objected to by			* *			
	inder 35 U.S.C. § 119			10 102.			
_	-	forcion priority under 25 11 C	0 0 440(a) (d) (6)				
_	12)⊠ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a)⊠ All b)□ Some * c)□ None of:						
a)	<i>'</i> _	umanta haya baan rassiyad					
	1. Certified copies of the priority doc						
	2. Certified copies of the priority doc3. Copies of the certified copies of the		· · · — — — — — — — — — — — — — — — — —	J Ctomo			
	 Copies of the certified copies of the application from the International 			ii Stage			
* 5	see the attached detailed Office action fo	, , , , , , , , , , , , , , , , , , , ,					
	and attached detailed Office action to	a hat of the certified copies	TIOL FECEIVEU.				
Amant	W-3						
Attachmen 1\ ⊠ Notic	` '	 □	January (DTO 440)				
	e of References Cited (PTO-892) e of Draftsperson's Patent Drawing Review (PTO-		view Summary (PTO-413) r No(s)/Mail Date				
3) 🔲 Inforr	nation Disclosure Statement(s) (PTO/SB/08)	5) Notic	e of Informal Patent Application				
Paper No(s)/Mail Date 6) [_] Other:							

Response to Remarks

1. Applicant's Amendment filed on September 20, 2006 has been fully considered. The rewritten of Claims 13, 15 and 18 in independent form are now rejected with the prior art of Wakabayashi et al. in view of Oinoue et al. because a further consideration of Applicant's claimed limitations are disclosed in the cited prior art.

Claim Rejections - 35 USC § 103

- 2. The following is a quotation of 35 U.S.C. § 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 13-18 are rejected under 35 U.S.C. 103 (a) as being unpatentable over Wakabayashi et al. (U.S. Patent 5,319,497) in view of Oinoue et al. (U.S. Patent 6,044,048).
- 4. Wakabayashi teaches an optical head very similar to that of the instant invention as recited in claims 13 and 14. For example, Wakabayashi teaches the following:

With respect to claim 13, a lens holder 2 for holding the objective lens 1 (Fig. 4); the objective lens 1 being configured to bring emitted light into focus (Fig. 4); a support shaft inserted in the bearing hole of the lens holder 2, such that the support shaft is substantially parallel to an optical axis of the objective lens (Figs. 2 and 5; line 0a shows a support shaft; a bearing hole to fit a support shaft is an inherent feature in this type of lens drive device so that the lens holder 2 can be rotated; column 1, lines 25-29); an inclination drive unit (lens drive coils and magnets) configured to turn the lens holder 2 on a first axis perpendicular (horizontally, incline or slant) to the support shaft based on detected information (Figs. 4 and 5; coils and magnets generates the driving force and accelerating force which turns/rotates the lens holder 2 in the direction θ which is perpendicular to the vertical axis 11a; detected information are focusing and tracking errors); at least part of the inclination drive unit being arranged on a second (horizontal) axis, which is substantially perpendicular to the support shaft and the first (vertical) axis (Fig. 4; magnets 3a, 3b etc. are positioned in horizontal axis); a focusing drive unit including a coil 8a, 8b wound around the support shaft, the focusing drive unit being configured to move the lens holder in a focusing direction based on the detected information (Figs. 2

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and 4; column 5, lines 31-41; coils 8a and 8b form a circle around the central supporting shaft).

However, Wakabayashi does not teach the following:

(i) a light detector for receiving the light reflected from the information recording medium in response to the emitted light.

Oinoue teaches the following:

(i) a light detector 27 for receiving the light reflected from the information recording medium 11 and outputting information about inclination (servo movements) of the objective lens relative to the information recording medium 11 on the basis of the light received (Figs. 5 and 6).

An optical pickup used in an optical information read/write system requires a light detector to detect a reflected light beam. In this case, although Wakabayashi's lens drive device does not include the necessary light detector to form the optical information read/write system, it would have been obvious to one of ordinary skill in the art to add the light detector such as Oinoue's, because the light detector provides detected information reflected from an recording medium to a lens servo control device so that Wakabayashi's objective lens can be driven by the servo control device.

(b) With respect the Claim 14, the prior art of Wakabayashi further teaches a tracking drive unit 3a, 3b, at

least part of the tracking drive unit being arranged on the first axis (Figs. 4 and 5; magnets 3a and 3b arranged/surrounded on the first axis are part of the tracking drive unit).

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- 5. Claim 15 has limitations similar to those treated in the above rejection, and is met by the references as discussed above.
- 6. With respect to Claims 16 and 17, Wakabayashi in view of Oinoue teach an optical head very similar to that of the instant invention as recited in Claims 13 and 14. However, Wakabayashi does not teach the following:
- (i) with respect to Claim 16, a controller having electrical connections to the inclination, tracking, and focusing drive units respectively;
- (ii) with respect to Claim 16, the controller is operable to apply a current to each electrical connection based on the detected light; and
- (iii) with respect to Claim 17, the light detector includes a 2 by 2 matrix of light receiving surfaces, each light receiving surface generating a signal based on the detected light, the controller being configured to apply the

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currents to the electrical connections based on the signals from the light receiving surfaces.

Oinoue teaches the following:

- (i) a controller 19 having electrical connections to the inclination, tracking, and focusing drive units respectively(Fig. 1);
- (ii) the controller 19 is operable to apply a current to each electrical connection based on the detected light 20 (Fig. 1); and
- (iii) the light detector 27'a includes a 2 by 2 matrix of light receiving surfaces A, B, C, D, each light receiving surface generating a signal based on the detected light, the controller being configured to apply the currents to the electrical connections based on the signals from the light receiving surfaces (Fig. 15).

An objective lens servo mechanism requires a controller to process and control the inclination, tracking and focusing of the lens. When these lens servo movements are applied to Wakabayashi's tracking and focusing coils, it would have been obvious to one of ordinary skill in the art to use a servo controller similar to Oinoue's, because the controller adjust the inclination, tracking and focusing direction of the lens holder by supplying current in form of electrical signals to respective servo motors.

Furthermore, in order to adjust the servo movements according to the lens holder positions, it would have been obvious to one of ordinary skill in the art to use a 2 by 2 matrix light receiving surfaces such as Oinoue's in Wakabayashi's lens drive device, because light receiving means detect the light beam pass through the objective lens. The detect light beam is converted to electrical signals such as tracking and focusing error to the servo controller so that servo signal in form of current is applied to the respective servo drive motors.

- 7. Claim 18 has limitations similar to those treated in the above rejection, and is met by the references as discussed above. Claims 18 however also recites the following limitation which is also taught by the cited prior art of Wakabayashi:
- (i) with respect to Claim 18, a pair of magnets 6a, 6b mounted on the base 10, such that the magnets are arranged on the second (horizontal) axis on either side of the support axis (Fig. 4).

8. Claim 19 is rejected under 35 U.S.C. 103 (a) as being unpatentable over Wakabayashi et al. (U.S. Patent 5,319,497) in view of Oinoue et al. (U.S. Patent 6,044,048) and Nii et al. (U.S. Patent 6,574,186).

- 9. With respect to Claim 19, Wakabayashi in view of Oinoue teach an optical head very similar to that of the instant invention as recited in Claim 18. However, both Wakabayashi and Oinoue do not teach the following:
- (i) with respect to Claim 19, a magnetic fluid within the bearing hole.

Nii teaches the following:

(i) a magnetic fluid 5 within the bearing hole (Fig. 1; column 3, lines 54 and 55).

A rotating shaft in a bearing hole such as Wakabayashi's requires a lubricating oil to reduce the frictional force between the shaft and the hole. When there are air bubbles in the oil which affects the stability of the shaft, it would have been obvious to one of ordinary skill in the art to replace the lubricating oil in Wakabayashi's bearing hole with the magnetic fluid of Nii's, because the magnetic fluid acts as both a lubricant and a stabilizer to the rotating shaft under the surrounding magnetic fields.

Allowable Subject Matter

- 10. Claims 1-11 are allowable over prior art.
- 11. The following is an Examiner's statement of reasons for the indication of allowable subject matter:

As in claims 1 and 9, the prior art of record fails to teach or fairly suggests that the bearing hole having a diameter that increases while approaching the bearing hole's openings from the bearing hole's center.

The features indicated above, in combination with the other elements of the claims, are not anticipated by, nor made obvious over, the prior art of record.

Conclusion

12. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Nose et al. (5,791,785) is pertinent because Nose teaches a bearing means filled with magnetic lubricant.

13. Any inquiry concerning this communication or earlier communication from the examiner should be directed to Kim CHU whose telephone number is (571) 272-7585 between 9:30 am to 6:00 pm, Monday to Friday.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, William Korzuch, can be reached on (57) 272-7589.

The fax number for the organization where this application or proceeding is assigned is (571) 273-8300

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Kim-Kwok CHU

Examiner AU2627 October 17, 2006

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